



PATENT  
81716.0122

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Isamu AKASAKI, et al

Serial No: 10/810, 309

Filed: March 26, 2004

For: SEMICONDUCTOR APPARATUS,  
METHOD FOR GROWING NITRIDE  
SEMICONDUCTOR AND METHOD  
FOR PRODUCING SEMICONDUCTOR  
APPARATUS

Date of NOA: December 2, 2005

Art Unit: 2814

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P.O. Box 1450  
Alexandria, VA 22313-1450, on

March 1, 2006

Date of Deposit

Wendy McLaren

Name  
*Wendy McLaren* 3/1/06  
Signature Date

**TRANSMITTAL OF ISSUE FEE**

Mail Stop ISSUE FEE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Notice of Allowance dated December 2, 2005, enclosed are the following:

- ☒ Form Part B - Issue Fee Transmittal, Advance Order for 4 patent copies.
- ☒ Comments on Statement of Reasons for Allowance.

The Commissioner is hereby authorized to charge any deficiency in payment or credit any overpayment to Deposit Account No. 50-1314. A copy of this Transmittal is enclosed.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

Date: March 1, 2006

By: *Lawrence J. McClure*  
Lawrence J. McClure  
Registration No. 44,228  
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Patent Application No. 10/810,309  
Attorney Docket No. 81716.0122

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Name

Signature

Date

Comments on Statement of Reasons for Allowance

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In the Notice of Allowance dated December 2, 2005, the Office has identified one reason why the presently claimed invention may patentably distinguish over the prior art. Applicant, however, respectfully submits that there are or may be additional reasons why the presently claimed invention may patentably distinguish over the prior art. As such, the Office's stated reasons should not be construed to be the sole basis for patentability of the present invention.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

Date: March 1, 2006

By:

Lawrence J. McClure  
Registration No. 44,228  
Attorney for Applicant(s)

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